



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant: § Art Unit: 2814
Ilya Karpov et al. §
Serial No.: 10/822,361 § Examiner: Long Pham
Filed: April 12, 2004 § Docket: ITL.0835D1US
For: Fabricating Deeper and Shallower § Assignee: Intel Corporation
Trenches in Semiconductor Structures § Conf. No. 3077

Mail Stop **RCE**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION

Sir:

Pursuant to 37 C.F.R. § 1.114(c), please consider the following claim amendments and remarks.

Date of Deposit: December 21, 2006
I hereby certify under 37 CFR 1.8(a) that this correspondence is
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Nancy Meshkoff